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Patent

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Customer No.: 31561
Application No.: 10/605,160
Docket No. 11439-US-PA

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Applicant : WEN-PIN CHIU
Application No. : 10/605,160
Filed : September 12, 2003
For : IONIZED PHYSICAL VAPOR DEPOSITION PROCESS
Art Unit : 1753
Examiner : MCDONALD, RODNEY GLENN

TRANSMITTAL LETTER

+1-571-273-8300
(Via fax: 1+2+9 pages)

ASSISTANT COMMISSIONER FOR PATENTS
Alexandria, VA 22314

Dear Sir,

In response to the Final Office Action dated February 20, 2007, please find the relevant papers as follows:

- Request for Continued Examination in (2) pages;
- Preliminary Amendment in (9) pages.

Thank you for your assistance in the subject matter. If you have any questions, please feel free to contact me.

Respectfully Submitted,
JIANQ CHYUN Intellectual Property Office

Date: May 16, 2007

By: Belinda Lee
Belinda Lee
Registration No.: 46,863

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